

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN THE MATTER OF: EUN, et al  
SERIAL NO: 10/539,886  
FILED: June 17, 2005  
TITLE: METHOD FOR PREPARING FILM STRUCTURE  
COMPRISING  
FERROELECTRIC SINGLE CRYSTAL  
LAYER  
GROUP: 1791  
CONFIRMATION NO: 1951  
EXAMINER: Sonya MAZUMDAR

**AMENDMENT**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Ok to Enter  
/S.M./

MAIL STOP: AMENDMENT

SIR:

This is in response to the outstanding office communication dated March 17, 2008. Applicant respectfully requests that any insufficient fees be deducted from our deposit account 504581.

Please amendment the application as follows: